IN THE UNITED STATES PATENT AND TRADEMARK OFFICE AY 2006

Applicant(s) : Terry L. Alford et al.

Application Serial Number : To be assigned Date of Filing : May 9, 2006

Title : FLEXIBLE ELECTRONICS USING ION IMPLANTATION

TO ADHERE POLYMER SUBSTRATE TO SINGLE

CRYSTAL SILICON SUBSTRATE

Group Art Unit : To be assigned Examiner : To be assigned

USPTO Customer No. : 26707

Attorney Docket No. : 112624.00062

INFORMATION DISCLOSURE STATEMENT PURSUANT TO 37 C.F.R. § 1.97

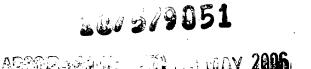
Commissioner for Patents U.S. Patent & Trademark Office P.O. Box 1450 Alexandria, VA 22313

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Applicant hereby brings to the attention of the Examiner the documents noted on the accompanying Form PTO-1449. This Information Disclosure Statement is being filed prior to the mailing date of a first Office Action.

It is respectfully requested that the information cited herein be expressly considered during the prosecution of this application and made of record on any patent to issue therefrom. Inclusion of a reference on the enclosed Form PTO-1449 is not to be construed as indicating the reference is prior art with respect to the subject application. Submission of this Information Disclosure Statement is not to be taken as evidence that a search has been conducted.

Terry L. Alford *et al*. Information Disclosure Statement



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Respectfully submitted,

QUARLES & BRADY STREICH LANG, LLP

May <u>9</u>, 2006

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AP20 Rec'd PCT/PTO 09 MAY 2006

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	INFORMATION DISCLOSURE	Filing Date	May 9, 2006	
		First Named Inventor	Terry L. Alford	
	STATEMENT BY APPLICANT	Art Unit	To be assigned	
	(Use as many sheets as necessary)	Examiner Name	To be assigned	
$\overline{}$	Sheet 1 of 2	Attorney Docket Number	112624.00062	

U. S. PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
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INF	ORMATION	DIS	CLOSURE	Filing Date	May 9, 2006
STA	TEMENT E	SY A	PPLICANT	First Named Inventor	Terry L. Alford
				Art Unit	To be assigned
(Use as many sheets as necessary)			ecessary)	Examiner Name	To be assigned
Sheet	2	of	2	Attorney Docket Number	112624.00062

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Examiner Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-number(s), publisher, city and/or country where published.		T ²			
	Α	Hochbauer et al., "Physical mechanisms behind the ion-cut in hydrogen implanted silicon", J. Appl. Phys., 92(5):2335-2342, 2002			
	В	B Hochbauer et al., "Investigation of the cut location in hydrogen implantation induced silicon surface layer exfoliation", J. Appl. Phys., 89(11):5980-5990, 2001			
	С	Hochbauer et al., "Hydrogen blister in boron and hydrogen coimplanted n-type silicon", Appl. Phys. Lett., 75(25):3938-3940, 1999			
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